

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,794,868 B1
DATED : September 21, 2004
INVENTOR(S) : Wai Ha Wong and Weston A. Anderson

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

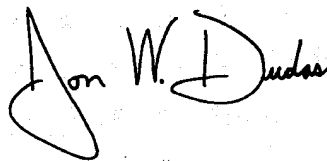
Column 8,

Line 61, should read as follows:

-- A method of determining shim coil setting when number of probe cells is greater than number of shim coils, comprising the steps of:
 applying currents to said shim coils;
 measuring resonant frequencies from said probe cells, and
 optimizing the currents of said shim coils by using a least square of errors of frequencies from a desired set of resonant frequencies. --.

Signed and Sealed this

Thirtieth Day of May, 2006

A handwritten signature in black ink, reading "Jon W. Dudas". The signature is stylized with a large, looping initial "J" and a distinct "D".

JON W. DUDAS
Director of the United States Patent and Trademark Office